

## CLAIMS

Therefore, having thus described the invention, at least the following is claimed.

- 1    1.    A microstructure, comprising:  
2                a substrate;  
3                an overcoat layer disposed upon the substrate;  
4                an air-region within at least a portion of the overcoat layer; and  
5                a framing material layer engaging at least a portion of the air-region on  
6                an inside surface of the framing material layer, and engaging the overcoat layer  
7                on an outside surface of the framing material layer.
  
- 1    2.    The microstructure of claim 1, wherein the overcoat layer is selected from  
2                polyimides, polynorbornenes, epoxides, polyarylenes ethers, polyarylenes,  
3                inorganic glasses, and combinations thereof.
  
- 1    3.    The microstructure of claim 1, wherein the framing material is selected from  
2                SiO<sub>2</sub>, Si<sub>3</sub>N<sub>4</sub>, SiO<sub>x</sub>N<sub>y</sub> (where x is from 0.01 to 2 and y is from 0.01 to 1.33), and  
3                Al<sub>2</sub>O<sub>3</sub>.
  
- 1    4.    The microstructure of claim 1, wherein the air-region has a height from about  
2                0.01 to 100 micrometers and a width of about 0.1 to 10,000 micrometers.
  
- 1    5.    The microstructure of claim 1, wherein the framing material has a thickness of  
2                about 0.001 to 10 micrometers.
  
- 1    6.    The microstructure of claim 1, wherein the framing material has a thickness of  
2                about 0.01 to 2 micrometers.

1     7.     The microstructure of claim 1, further comprising a plurality of air-regions  
2           disposed within the overcoat layer, the framing material layer of each of the  
3           plurality of air-regions engaging at least a portion of each air-region on the  
4           inside surface of the framing material layer and engaging the overcoat layer on  
5           the outside surface of the framing material layer.

1     8.     The microstructure of claim 7, wherein the air-regions are positioned at  
2           multiple height levels within the overcoat layer.

1     9.     The microstructure of claim 8, wherein a first air-region is positioned above  
2           and substantially in-line with a second air-region.

1     10.    The microstructure of claim 8, wherein a first air-region is positioned above  
2           and substantially offset from a second air-region.

1     11.    A microstructure, comprising:  
2           a substrate;  
3           an overcoat layer disposed upon the substrate;  
4           a sacrificial polymer layer disposed within at least a portion of the  
5           overcoat layer; and  
6           a framing material layer engaging at least a portion of the sacrificial  
7           polymer layer on an inside surface of the framing material layer and engaging  
8           the overcoat layer on an outside surface of the framing material layer.

1     12.    The microstructure of claim 11, wherein the overcoat layer is selected from  
2           polyimides, polynorbornenes, epoxides, polyarylenes ethers, parylenes,  
3           inorganic glasses, and combinations thereof.

1     13.    The microstructure of claim 11, wherein the framing material is selected from  
2           SiO<sub>2</sub>, Si<sub>3</sub>N<sub>4</sub>, SiO<sub>x</sub>N<sub>y</sub> (where x is from 0.01 to 2 and y is from 0.01 to 1.33), and  
3           Al<sub>2</sub>O<sub>3</sub>.

- 1 21. The method of claim 18, wherein the framing material is selected from  $\text{SiO}_2$ ,  
2  $\text{Si}_3\text{N}_4$ ,  $\text{SiO}_x\text{N}_y$  (where x is from 0.01 to 2 and y is from 0.01 to 1.33), and  
3  $\text{Al}_2\text{O}_3$ .
- 1 22. The method of claim 18, wherein the sacrificial layer polymer is selected from  
2 polyimides, polynorbornenes, epoxides, polyarylenes ethers, polyarylenes,  
3 inorganic glasses, and combinations thereof.
- 1 23. A method for fabricating a microstructure, comprising:  
2 providing a structure having a substrate, an overcoat layer, a sacrificial  
3 polymer layer in an area within the overcoat layer, and a framing material  
4 between at least a portion of the sacrificial polymer layer and the overcoat  
5 layer; and  
6 removing the sacrificial polymer layer to form an air-region within the  
7 area defined by the sacrificial material.
- 1 24. The method of claim 23, wherein the sacrificial layer polymer is solvent-  
2 incompatible with the overcoat.

- 1 14. The microstructure of claim 11, wherein the sacrificial layer polymer is  
2 selected from polyimides, polynorbornenes, epoxides, polyarylenes ethers,  
3 parylenes, inorganic glasses, and combinations thereof.
- 1 15. The microstructure of claim 11, wherein the sacrificial layer polymer is solvent  
2 incompatible with the overcoat.
- 1 16. The microstructure of claim 11, wherein the sacrificial layer polymer has a  
2 height from about 0.01 to 100 micrometers and a width of about 0.1 to 10,000  
3 micrometers.
- 1 17. The microstructure of claim 11, wherein the framing material has a thickness  
2 of about 0.001 to 10 micrometers.
- 1 18. A method for fabricating a microstructure, comprising:  
2 providing a substrate having a sacrificial polymer layer disposed  
3 thereon;  
4 disposing a framing material onto at least a portion of the sacrificial  
5 polymer layer; and  
6 disposing an overcoat layer onto the framing material, wherein the  
7 framing material substantially separates the sacrificial polymer layer from the  
8 overcoat layer.
- 1 19. The method of claim 18, further comprising:  
2 removing the sacrificial layer to define an air-region within the  
3 overcoat layer, the framing material engaging at least a portion of the air-  
4 region on an inside surface of the framing material and engaging the overcoat  
5 layer on an outside surface of the framing material.
- 1 20. The method of claim 18, wherein the overcoat layer is selected from  
2 polyimides, polynorbornenes, epoxides, polyarylenes ethers, parylenes,  
3 inorganic glasses, and combinations thereof.